

**DRAFT AMENDMENT UNDER 37 C.F.R. § 1.116
EXPEDITED PROCEDURE
GROUP 1792
PATENT APPLICATION**

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of

Docket No: Q87929

Jean-Michel RIUS , et al.

Appln. No.: 10/536,902

Group Art Unit: 1792

Confirmation No.: 4716

Examiner: Joseph Albert MILLER JR

Filed: May 27, 2005

For: METHOD AND DEVICE FOR MICROWAVE PLASMA DEPOSITION OF A
COATING ON A THERMOPLASTIC CONTAINER SURFACE

AMENDMENT UNDER 37 C.F.R. § 1.116

MAIL STOP AF

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

Sir:

In response to the Office Action dated February 19, 2009, please amend the above-identified application as follows on the accompanying pages.

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